

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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| APPLICANTS: | Jin-Hwa Heo | EXAMINER: | Maki A. Angadi |
| SERIAL NO.: | 10/734,354 | ART UNIT: | 1792 |
| FILED: | December 12, 2003 | DOCKET: | 8836-140 DiV (IE10178-US-1) |
| TITLE: | SEMICONDUCTOR DEVICE HAVING TRENCH ISOLATION LAYER AND A METHOD OF FORMING THE SAME | | |

Mail Stop Issue Fee
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 312

Sirs:


Applicants appreciate the Examiner's issuance of the Notice of Allowability and Supplemental Notice of Allowability.

The both Notices indicates that no foreign priority document under 35 U.S.C. § 119(a)-(d) or (f) had been received. Applicant respectfully disagrees with the Examiner's indication. The Korean Priority Application 2001-12603 filed 12 March 2001 was originally filed in the parent case U.S. Serial No. 09/990,740 filed on November 16, 2001, which since has issued as U.S. Patent No. 6,683,354 on January 27, 2004.

Applicant respectfully request an issuance of a Second Supplemental Notice of Allowability indicating that a certified copy of the above-mentioned priority document have been received in Application No. 09/990,740.

Respectfully submitted,

By:



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